The prospective application of a graphene/MoS2 heterostructure in Si-HIT solar cells for higher efficiency†

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The efficiency of a Si-HIT (heterojunction with intrinsic thin layer) solar cell based on a graphene/MoS2 heterostructure has been optimized by varying the various parameters of graphene (Gr) as a transparent conducting electrode (TCE) and n-type molybdenum disulfide (n-MoS2) as an emitter layer. The photovoltaic performance of a graphene/n-MoS2/a-Si:H/p-cSi/Au single facial HIT solar cell has been studied using AFORS-HET v2.5 simulation software. A maximum output efficiency of 25.61% has been achieved. The obtained results were compared with the results from a commercially available a-Si:H layer and p-cSi wafer after simulation. Moreover, the dependence of the cell performance on changes in the TCE and the back contact materials has also been studied. Finally, it has been demonstrated that the graphene layer and n-MoS2 layer could act as a TCE and an efficient emitter layer, respectively, in a n-MoS2/p-cSi based HIT solar cell.

1. Introduction

The output efficiency (η) of a simple silicon (Si) heterojunction solar cell degrades owing to the presence of a large number of defects at the surface of the Si wafer. This deficiency of heterojunction solar cells can be overcome by the introduction of a thin intrinsic layer between the two doped layers of the heterojunction. Such a structure is known as a heterojunction with intrinsic thin layer (HTJ) structure.1 In a HIT structured solar cell, the intrinsic layer-like a-Si:H reduces the interfacial recombination state density to the minimum level between two doped layers2 and reduces the leakage current.3 Recently, SANYO Ltd reported attaining a 20% output efficiency in HIT solar cells based on n-type Si.4 Furthermore, Panasonic has achieved the world’s highest efficiency of 25.6% in a HIT cell based on an n-type c-Si.5

In a solar cell, a transparent conductive electrode (TCE) is required to ensure the easy transportation of carriers from the emitter layer to the external circuit. The low sheet resistance (10 Ω sq−1) and high optical transparency (85%) mean that indium tin oxide (ITO) is a commonly used TCE in photovoltaic (PV) applications. However, the high cost, rarity and mechanical rigidity of ITO have limited its use for future flexible devices and these drawbacks initiated the search for new TCE materials.6

Recently, pristine graphene has been reported to have an optical transparency as high as 97.7% (single layer graphene) with a work function of 4.31–4.5 eV (ref. 7 and 8) and a sheet resistance of 120 Ω sq−1 in few-layer graphene.6 In addition, the intercalated graphene with ferric chloride is reported to have a high optical transparency of approximately 96% with a low sheet resistance of 8.8 Ω sq−1 and a high carrier density of 8.9 × 1014 cm−2 at room temperature and a high stability in air.4 At room temperature, the carrier mobility in the graphene layer exceeds 105 cm2 V−1 s−1.7 These extraordinary properties have led to the application of multilayer graphene as a TCE. Recently, Lazar et al.7 reported that doping with boron (B) and –NH2 can increase the work function of graphene (ΦGr) to 1.20 eV and 0.46 eV from 4.31 eV (pristine graphene). Kim et al.8 demonstrated that, after being irradiated by an α beam the work function of graphene increases to 4.9 eV. Conversely, the low photoresponsivity, poor external quantum efficiency, and low absorption of light reduces the application of graphene as an emitter layer instead of the TCE layer in HIT solar cell.10 Unlike graphene, another 2D material, molybdenum disulfide (MoS2) has emerged as a complement 2D material for graphene as an emitter layer in HIT solar cells. MoS2 has a mobility of 200 cm2 V−1 s−1 in the monolayer and approximately 517 cm2 V−1 s−1 in few layers, as well as a high on/off ratio in the order of 108 (ref. 11 and 12) and a fast photo-response time of 40 µs.13 MoS2 is reported to have an indirect bandgap of 1.2 eV in the bulk form and a direct bandgap of 1.9 eV in the single layer form.14 Moreover, double layer MoS2 has more than 85% optical transparency in the visible region.15 Recently, it has been reported that the work function of MoS2 changes with a change in the number of layers.16 It has also been demonstrated that MoS2

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can be used to form significant n-type doping with a Benzyl Viologen (BV) dopant\textsuperscript{17} and polyethyleneimine (PEI)\textsuperscript{18}. PEI reduces the sheet resistance of MoS\textsubscript{2} 2.6 times.\textsuperscript{18} These properties mean that MoS\textsubscript{2} can be utilized as an emitter layer in MoS\textsubscript{2}/silicon HIT solar cells.

Experimentally and theoretically, it has been demonstrated that MoS\textsubscript{2} can act as an emitter layer in heterojunction silicon solar cells. Tsai \textit{et al.}\textsuperscript{19} fabricated a heterojunction solar cell of monolayer MoS\textsubscript{2} and p-cSi and achieved a power conversion efficiency of 5.23%. Hao \textit{et al.}\textsuperscript{20} also fabricated a bulk p-n junction after depositing a 40 nm thick layer of n-MoS\textsubscript{2} onto p-cSi substrates and a 1.3% photoconversion efficiency was achieved.

The high transparency, as well as the high mobility of the graphene layer with a tunable bandgap and work function, along with practical and theoretical demonstrations of graphene/MoS\textsubscript{2} and MoS\textsubscript{2}/Si heterojunctions, motivated us to propose a single facial HIT solar cell structure of graphene/n-MoS\textsubscript{2}/MoS\textsubscript{2}/Si:H/p-cSi/Au. Here, we have used graphene as a TCE material. No reports have been published on the use of graphene as an effective TCE material in a n-MoS\textsubscript{2}/p-cSi HIT solar cell. The high transparency, as well as the high mobility of the graphene layer with a tunable bandgap and work function, along with practical and theoretical demonstrations of graphene/MoS\textsubscript{2} and MoS\textsubscript{2}/Si heterojunctions, motivated us to propose a single facial HIT solar cell structure of graphene/n-MoS\textsubscript{2}/MoS\textsubscript{2}/Si:H/p-cSi/Au. Here, we have used graphene as a TCE material. No reports have been published on the use of graphene as an effective TCE material in a n-MoS\textsubscript{2}/p-cSi HIT solar cell.

2. Physical model, structural model and formation of the junctions

2.1 Physical model

AFORS-HET is solar cell simulation software, used to study and analyze the various properties of a heterojunction solar cell. For the proposed structure, this software solves Poisson’s equation and the transport equation for electrons and holes in one dimension. These equations are as follows:

\[
\frac{\varepsilon_0 e_T}{q} \frac{\partial^2 \phi(x,t)}{\partial x^2} = p(x,t) - n(x,t) + N_D - N_A + \sum_{\text{defects}} \rho_i(x,t)
\]

\[-\frac{1}{q} \frac{\partial j_n(x,t)}{\partial x} = G_n(x,t) - R_n(x,t) - \frac{\partial}{\partial t} n(x,t)
\]

\[\quad \frac{1}{q} \frac{\partial j_p(x,t)}{\partial x} = G_p(x,t) - R_p(x,t) - \frac{\partial}{\partial t} p(x,t)
\]

In which, \(n\) represents the electron density, \(p\) is the hole density, \(\phi\) is the electric potential, \(q\) is the electron charge, \(\varepsilon_0 e_T\) is the absolute-relative dielectric constant, and \(N_{D/A}\) represents the donors/acceptors concentrations, which are supposed to be completely ionized. Here, \(n, p\) and \(\phi\) are the independent variables for which the system of differential equations is solved.

The charge stored in the defects is described by a distribution function, \(f_d\) specifying the probability that defects with a defect density \(N_d\) are at position \(E\) if the bandgap is occupied with electrons:

\[
\text{Accepter-type defect} : \rho_i(x,t) = -\int dE_j(E,x,t)N_i(E)
\]

\[
\text{Donor-type defect} : \rho_i(x,t) = -\int dE_j[1-f_i(E,x,t)]N_i(E)
\]

The electron/hole currents \(j_{n/p}\) flow owing to the gradient of the corresponding quasi-Fermi energy \(E_{\text{F,n/p}}\). Within the semiconductor layer, this is equivalent to the sum of the diffusion and drift current with the corresponding mobility \(\mu_{n/p}\):

\[
j_n(x,t) = q\mu_n n(x,t) \frac{\partial E_{\text{F,n}}(x,t)}{\partial x} = -\mu_n kT \frac{\partial n(x,t)}{\partial x} + q \mu_n n(x,t) \frac{\partial \phi(x,t)}{\partial x}
\]

\[
j_p(x,t) = q\mu_p p(x,t) \frac{\partial E_{\text{F,p}}(x,t)}{\partial x} = -\mu_p kT \frac{\partial p(x,t)}{\partial x} - q \mu_p p(x,t) \frac{\partial \phi(x,t)}{\partial x}
\]

If the heterostructure is illuminated (specifying the spectral distribution \(\phi(\lambda)\) of the incoming photon flux), the super-bandgap optical generation rate \(G_n = G_p\left(\frac{\hbar c}{\lambda} \approx E_g\right)\) from the valence band into the conduction band of the semiconductor layers can be evaluated by considering the Lambert-Beer absorption model by specifying the spectral absorption coefficient \(\alpha\), as well as specifying the dielectric properties \((\varepsilon,\varepsilon_r)\) of each layer. An optical sub-bandgap generation \((\text{for } \frac{\hbar c}{\lambda} < E_g)\) from a defect to the conduction/valence band can be defined by specifying the optical emission coefficients \(\epsilon_{\text{em}}(E)\), \(\epsilon_{\text{em}}(E) \neq 0\) for the defect state.

Recombination from the conduction band into the valance band may occur directly (band to band recombination, Auger recombination) and via trap states (Shockley-Read-Hall recombination, (SHR)).

\[
R_{n,p}(x,t) = R_{n,p}^{\text{Band-Band}}(x,t) + R_{n,p}^{\text{Auger}}(x,t) + R_{n,p}^{\text{SRH}}(x,t)
\]

The transportation across the heterojunction interface is modeled by drift-diffusion. In order to do so, an interface layer is considered. The specified interface defects are distributed homogeneously within this layer. The cell currents have to be
evaluated directly from the gradient of the corresponding quasi-Fermi energies. The electron affinity ($\chi$), the bandgap ($E_g$) and the effective conduction/valence band density of states ($N_C, N_V$) will depend on the position $x$ within the interface layer.

$$E_{F_n}(x) = -q\chi(x) + q\varphi(x) - kT \ln \frac{n(x)}{N_C(x)}$$

$$E_{F_p}(x) = -q\chi(x) + q\varphi(x) + kT \ln \frac{n(x)}{N_V(x)}$$

The electric potential is fixed to zero at one contact. At the second contact, a boundary condition has to be specified, which relates the external cell voltage/current to the internal quantities. Furthermore, the electron and hole currents moving into the metal contacts need to be modeled. The Schottky contact can either be voltage controlled, or current controlled.

2.2. Structural model

Layered structure MoS$_2$ can be directly deposited on Si substrates. However, owing to their structural mismatch (i.e. layered structure of MoS$_2$ and diamond-like structure of Si), large quantities of lattice defects are produced and this increases the recombination at the interface. Thus, the introduction of an intrinsic (i) buffer layer a-Si:H could be beneficial to balance the carrier injection and reduce the leakage current.

Fig. 1  (a) The proposed HIT solar cell structure, and (b) band diagram as generated using AFORS-HET software for the proposed structure.
in the cell. Therefore, the as-synthesized MoS2 is an n-type semiconductor and p-type silicon is more popular in the PV industries. Thus, in this simulation, we have used p-cSi as a base material. Moreover, the minority carrier diffusion length in p-cSi is also reported to be higher than n-cSi. Furthermore, Fan et al. have reported that ultrathin gold (Au) contacts provide a better electrical conductivity and optical reflectance-scattering to maintain the performance of the cell compared with ITO. Also, it has been demonstrated that an Au/Si interface formed by using novel transfer printing technology makes excellent electrical contact and exhibits a low contact resistance in comparison to that formed by vacuum deposition of Au on Si. Therefore, the proposed structure of the single facial HIT solar cell is configured as graphene/n-MoS2/a-Si:H(i)/p-cSi/Au, as shown in Fig. 1. No lattice mismatch between the layers has been considered for this simulation. Ideally, a semiconductor is called 2D if it satisfies the condition \( t \leq \lambda_F \), in which \( t \) is the average system of the 2D electron system, \( \lambda_F \) is the Fermi wavelength which is equal to \( \frac{2\pi}{n_{2D}} \) nm, and \( n_{2D} \) is the carrier density in cm\(^{-2}\). Following this condition as reported by Sarma et al. and Suh et al. even \( n \sim 10^{15} \text{ cm}^{-3} \) in graphene and \( n \sim 1.8 \times 10^{14} \text{ cm}^{-3} \) in MoS2 cannot satisfy the above described conditions respectively. It has also been reported that doping in 2D materials increases the interlayer spacing. Thus, we consider graphene and MoS2 quasi 3D in nature instead of 2D. The quantum confinement in the structure was achieved by controlling the layer number of n-MoS2. In the proposed HIT structure, as shown in Fig. 1a the carrier transport occurred along the c-axis. Details of the front contact and the back contact parameters of the proposed structure are given in Table 1 and the parameters, as well as the ranges of the n-MoS2, a-Si:H and p-cSi are given in Table 2. The thickness of the single graphene was taken as 0.334 nm and the monolayer MoS2 as 0.65 nm. However, we started our simulation from five-layer (5L) graphene (1.67 nm) and six-layer (6L) MoS2 (3.9 nm) by considering the high overlapping probability of the graphene and p-cSi. It was also reported that the Raman spectrum of 6L MoS2 is very close to the bulk and the optical transparency of 5L graphene (88.5%) is more than that of ITO (85%). The parameters considered for optimization of the MoS2 layer were the donor concentration \( N_D \), \( N_C/N_V \), \( E_G \), layer thickness, \( \chi \), dielectric constant \( (\varepsilon_r) \) and electron mobility \( (\mu_e) \). The values of these parameters were kept within range and these and the results of the above mentioned previous literature are tabulated in Table 2. 

### Table 1: Front and back contact parameters

<table>
<thead>
<tr>
<th>Parameter</th>
<th>Front contact</th>
<th>Back contact</th>
</tr>
</thead>
<tbody>
<tr>
<td>Material</td>
<td>Initially</td>
<td>After optimization</td>
</tr>
<tr>
<td>Thickness</td>
<td>1L–5L (1L = 0.334 nm)</td>
<td>80 nm</td>
</tr>
<tr>
<td>Optical properties</td>
<td></td>
<td>ITO nk (default)</td>
</tr>
<tr>
<td>( n )</td>
<td>2.7</td>
<td>( n = 1.19 )</td>
</tr>
<tr>
<td>( k )</td>
<td>1.45</td>
<td>( k = 7.05 )</td>
</tr>
<tr>
<td>Work function (eV)</td>
<td>4.31</td>
<td>4.4</td>
</tr>
<tr>
<td></td>
<td>4.50</td>
<td>4.45</td>
</tr>
<tr>
<td></td>
<td>4.54</td>
<td>4.5</td>
</tr>
<tr>
<td></td>
<td>4.77</td>
<td></td>
</tr>
<tr>
<td></td>
<td>4.90</td>
<td></td>
</tr>
<tr>
<td>Absorption loss</td>
<td>0.023 (constant)</td>
<td>ITO abs (default)</td>
</tr>
<tr>
<td>External reflection</td>
<td>1L = 0</td>
<td>ITO Ref (default)</td>
</tr>
<tr>
<td></td>
<td>2L = 0.023</td>
<td></td>
</tr>
<tr>
<td></td>
<td>3L = 0.046</td>
<td></td>
</tr>
<tr>
<td></td>
<td>4L = 0.070</td>
<td></td>
</tr>
<tr>
<td></td>
<td>5L = 0.092</td>
<td></td>
</tr>
<tr>
<td>Surface condition</td>
<td>Plane</td>
<td>Plane</td>
</tr>
<tr>
<td>Internal reflection</td>
<td>0</td>
<td>0</td>
</tr>
</tbody>
</table>

The defect properties were kept as the default. Finally, we optimized the parameters of the contact materials, that is graphene, Au, ITO, Ag, and so forth. The work function \( (\Phi) \) and the number of layers were optimized and other parameters were fixed, as found in the literature.
Dielectric constant (εr)

Electron affinity (χ) (eV)

Band gap, Eg (eV)

Effective conduction band density, Nc (cm⁻³)

Effective valance band density, Nv (cm⁻³)

Effective electron mobility, μn (cm² V⁻¹ s⁻¹)

Effective hole mobility, μp (cm² V⁻¹ s⁻¹)

Acceptor concentration

Donor concentration

Electron thermal velocity, Ve (cm s⁻¹)

Hole thermal velocity, Vh (cm s⁻¹)

Layer density, (g cm⁻³)

Auger electron recombination coefficient, (cm⁶ s⁻¹)

Auger hole recombination coefficient, (cm⁶ s⁻¹)

Band-to-band recombination coefficient, (cm⁻¹)

Defect type

Defect charge

Total defect density (cm⁻³)

Specific defect density (cm⁻³ eV⁻¹)

Defect level energy (eV)

Electron and hole capture cross section (cm²)

Optical properties

Table 3 Interfacial Parameters

<table>
<thead>
<tr>
<th>Interface</th>
<th>Numerical model</th>
<th>Remarks</th>
</tr>
</thead>
<tbody>
<tr>
<td>Graphene/n-MoS2</td>
<td>MS-Schottky contact</td>
<td>Surface recombination velocity for electrons and holes = 10⁷ cm s⁻¹ (default)</td>
</tr>
<tr>
<td>p-cSi/Au</td>
<td></td>
<td></td>
</tr>
<tr>
<td>n-MoS2/a-Si:H</td>
<td>Drift diffusion model</td>
<td>Interface charge = 10⁻¹⁷ cm⁻²</td>
</tr>
<tr>
<td>a-Si:H/p-cSi</td>
<td></td>
<td></td>
</tr>
</tbody>
</table>

2.3 Formation of the junctions

If n-MoS₂ and p-cSi are brought into contact, a heterojunction forms and bending of the energy bands occur close to the Fermi level. This built-in potential (Vbi) is developed at the MoS₂/p-cSi interface. This voltage facilitates the separation of photo-generated carriers in the solar cell. Generally, in the p-n junction solar cell, the interfacial defect density reduces the overall efficiency of the cell. Therefore, better surface passivation between the two layers is required to reduce the defect density at the interface. Here, an intrinsic layer a-Si:H is inserted between n-MoS₂ and p-cSi. This layer can be deposited on Si using the plasma-enhanced chemical vapor deposition method at a low temperature (<200 °C) without degrading the bulk properties of the Si substrate. Also, it introduces band offsets between the active and emitter band which are also beneficial to obstructing the reverse flow of the charge carriers. The schematic energy band diagram of the proposed HIT solar cell is shown in Fig. 1b. The build-in potential (Vbi) in the HIT solar cell is defined as:

\[ eV_{bi} = E_g(MoS_2) + \Delta E_C + kT \ln\left(\frac{N_A N_D}{N_{V(Si)} N_{C(MoS_2)}}\right) \]

\[ = E_g(Si) - \Delta E_V + kT \ln\left(\frac{N_A N_D}{N_{V(Si)} N_{C(MoS_2)}}\right) \]

In which e, E₂, ΔE_C and ΔE_V, k and T are the electric charge, bandgap, the conduction band offset and valence band offset, Boltzmann constant, and the temperature in Kelvin, respectively. N_A and N_D represent the acceptor and donor concentrations and N_C and N_V are the conduction band and valence band density. In this HIT cell, a barrier for hole transportation is built at the interface between n-MoS₂ and the pristine graphene corresponding to the potential energy of eV_{bi} which can be expressed using the following equation:

\[ eV_{bi} = e(\Phi_{MoS_2} - \Phi_G) \]  

In which, \( \Phi_{MoS_2} \) and \( \Phi_G \) are the work functions of n-MoS₂ and pristine graphene respectively. As reported in previously published literature, the \( \Phi \) of a six layer MoS₂ (≈5.4 eV) is greater than that of pristine graphene (≈4.1 eV).

3. Results and discussion

3.1 Consequences of the n-MoS₂ layer

In this section, we have optimized the donor N_D of the n-MoS₂ layer in the range from 10¹² to 10¹⁸ cm⁻³, and other parameters such as the thickness, N_C/N_V, E₂, χ and εₚ are kept at feasible values as shown in Fig. 2a and b. In Fig. 2b, it can be seen that as
$N_D$ was increased from $10^{12}$ cm$^{-3}$ to $10^{16}$ cm$^{-3}$, the $V_{OC}$ remained constant at the value of 636.7 mV. At $N_D > 10^{16}$ cm$^{-3}$, the $V_{OC}$ increased to 646.1 mV as $N_D$ was increased to $10^{18}$ cm$^{-3}$. At a low value of $N_D$, the consistency of $V_{OC}$ indicates that it does not depend on $N_D$ unless the condition $\Delta N_D > 10^{16}$ cm$^{-3}$, as reported previously, is followed, as reported previously, as reported previously, in which $\Delta N_D$ represents the excess electron–hole pairs. At $N_D > 10^{16}$ cm$^{-3}$, the $V_{OC}$ increases owing to enhancement in the $eV_{bi}$ according to eqn (2). As the mobility of the photo-generated carriers remains almost constant even with an increase of $N_D$, this might keep $J_{SC}$ constant at 32.33 mA cm$^{-2}$. Similarly, the FF was found to be constant at 76.71% until the $N_D$ reached $10^{16}$ cm$^{-3}$ and then the FF slightly reduced to 75.73%. This is due to an increase in the recombination rate at a higher $N_D$ ($10^{18}$ cm$^{-3}$). As we have observed, the $N_D$ controls the $V_{OC}$, thus the $\eta$ of the cell remained constant at 15.79% as the $N_D$ increases, and a maximum of $\eta = 15.82\%$ was obtained at $N_D = 10^{18}$ cm$^{-3}$.

The $N_C/N_V$ is related to the effective mass of the electrons ($m_e^*$) and holes ($m_h^*$) as follows: $N_C/N_V \propto 2m_{e/h}^*$. Furthermore, $m_{e/h}^*$ is related to the mobility ($\mu_{e/h}$) as follows: $\mu_{e/h} = \frac{e\varepsilon_{r}}{m_{e/h}^*}$. From these two relationships, it can be concluded that with the change in mobility ($\mu_{e/h}$) the conduction and valence band density ($N_C/N_V$) also changes. It has been reported that the mobility of the charge carriers in MoS$_2$ changes with the change in the number of layer. MoS$_2$ has a mobility of 200 cm$^2$ V$^{-1}$ s$^{-1}$ in the monolayer and approximately 517 cm$^2$ V$^{-1}$ s$^{-1}$ in few layers. Therefore, after optimization of $N_D$ to $10^{18}$ cm$^{-3}$, the $N_C/N_V$ was optimized in the range $3 \times 10^{18}$ to $9 \times 10^{20}$ cm$^{-3}$ as shown in Fig. 2c and d. It can be seen in Fig. 2d that the $V_{OC}$ increased from 646.1 to 668 mV with an increase of the $N_C/N_V$.
from $3 \times 10^{18}$ cm$^{-3}$ to $10^{20}$ cm$^{-3}$. The increment in $V_{OC}$ can be understood by considering the equation: $V_{OC} = \frac{kT}{q} \ln \left( \frac{n p}{n_i^2} \right)$ in which $n_i$ is the carrier concentration, $n$ is the intrinsic electron concentration and $p$ represents the intrinsic hole concentration. Here, $n = n_o + \Delta n$ and $p = p_o + \Delta p$, in which $n_o$ and $p_o$ are the concentrations of the electrons and holes in the equilibrium condition and $\Delta n$, $\Delta p$ are the excess photo-generated electron and hole concentrations, respectively. As, $n p_o = n_i^2$, $n = N_D$ and $\Delta n = \Delta p$, $V_{OC}$ can therefore be rewritten as $V_{OC} = \frac{kT}{q} \ln \left( \frac{1 + \Delta p}{n_o^2} \frac{\Delta p^2}{n_i^2} + \frac{\Delta p N_D}{n_i^2} \right)$.57 We can assume that $V_{OC}$ increased with $N_C / N_V$ owing to an increase of $\Delta p$ and $\Delta n$. As shown in Fig. 2d, the $V_{OC}$ decreased a little bit to 666.4 mV as the $N_C / N_V$ increased to $9 \times 10^{18}$ cm$^{-3}$, which is due to the decrement of $eV_{bi}$ according to eqn (1). The $J_{SC}$ was found to remain constant at 32.33 mA cm$^{-2}$ with an increase of $N_C / N_V$ from $3 \times 10^{18}$ to $9 \times 10^{20}$ cm$^{-3}$. Although the generation rate ($G$) of the photo-generated carriers is reported to increase with higher values of $N_C / N_V$.58 The constant $J_{SC}$ indicates that the photo-generated carriers either recombine or are trapped close to the metal/semiconductor interface. As with the $V_{OC}$, the FF is also found to increase and a maximum value of 82.33% was obtained at $N_C / N_V = 3 \times 10^{19}$ cm$^{-3}$. Therefore, $\eta$ was found to be enhanced from 15.82% to a maximum value of 17.73%.

After optimization of the $N_D$ and $N_C / N_V$ to values of $10^{18}$ cm$^{-3}$ and $3 \times 10^{20}$ cm$^{-3}$, respectively, we varied the bandgap ($E_g$) in the range 1.41–1.47 eV (ref. 39) and results are shown in Fig. 2e and f. As we can see, all of the cell parameters are constant and a value of $\eta = 17.74\%$ was obtained in this range of $E_g$.

For the simulation with different numbers of layers of n-MoS$_2$ as shown in Fig. 2g and h, the $V_{OC}$ was found to remain constant at a value of 664.8 mV, whereas the $J_{SC}$ reduced from 33.63 to 32.33 mA cm$^{-2}$, when the number of layers was increased from 3 to 6. This happens because the number in the number of layers reduces the transmittance of photons to reach the junction, which results in a reduction of the electron–hole pair generation rate. The reduction of the transmittance with the increase in the n-MoS$_2$ layer number leads to a reduction of the FF. The $\eta$ was found to decrease from 18.54% to 17.74% as the number of layers increased from 3 to 6. Hence, we used 3L as the optimized number of layers of MoS$_2$ for further simulation.

Fig. 2i and j show the cell parameters for the optimization of $\chi$ in the ranges 3.7 to 4.1 eV. Here we have considered $E_g = 1.47$ eV for 3L MoS$_2$.44 The $V_{OC}$ remained constant at a value of 664.8 mV when $\chi$ (eV) was increased from 3.7 to 4 eV. Upon a further increase in the $\chi$ to 4.1 eV, a small increase in the $V_{OC}$ to approximately 691.4 eV was obtained owing to an increase in the $eV_{bi}$. A constant $J_{SC}$ of 33.63 mA cm$^{-2}$ was found in the range 3.74–3.90 eV of $\chi$ and this was enhanced to 34.16 mA cm$^{-2}$ for $\chi = 4.1$ eV. A small increase in the $\Delta E_C$ (see Fig. 1b) was observed with the increase in $\chi$, which leads to a slightly higher $V_{OC}$ and $J_{SC}$ at $\chi = 4.1$ eV. The FF was observed to increase from 82.93% (@ $\chi = 3.74$ eV) to 83.41% (@ $\chi = 4.1$ eV) as a result of the reduction in the sheet resistance. Therefore, $\eta$ was found to increase from 18.54% to 19.19%.

It has been found from electric transportation measurements that the dielectric response of the MoS$_2$ layers is sensitive to the substrate that is used and the dielectric effect relies on the thickness of the sample.41 The effect of the dielectric constant ($\varepsilon_r$) on the cell parameters is depicted in Fig. 2k and l. It can be observed in Fig. 2l, that the $V_{OC}$ does not depend on the variation of $\varepsilon_r$ and it was found to be a constant at 691.4 eV. However, the $J_{SC}$ shows a light decrement from 34.83 to 34.39 mA cm$^{-2}$ with an increase of $\varepsilon_r$ up to 14. In a p–n junction, $eV_{bi} \propto \frac{1}{\varepsilon_r}$, which affect the relative permittivity of the MoS$_2$ layer.54,57 The generation of the e–h pair increases in the MoS$_2$ layer with an increase in the $\varepsilon_r$ following Coulombs law as $F \propto \frac{1}{\varepsilon_r}$, in which $F$ is the electrostatic force between the electron and holes, but at the same time the increase in $\varepsilon_r$ reduces $eV_{bi}$. As a consequence of both of these effects, we obtained a constant $V_{OC}$. In contrast, under short circuit conditions, the photo-generated carriers experienced reduced $eV_{bi}$, which boosts the recombination of the carriers. Thus, the $J_{SC}$ was found to decrease. The FF showed a minor increase from 82.43% to 83.41% when $\varepsilon_r$ was increased from 4 to 6. After this the increase in FF slowed down and only reached 83.49% for $\varepsilon_r = 14$. In Fig. 2k, $\eta$ was found to largely depend on the $V_{OC}$ and remained constant at 19.91% with $\varepsilon_r$. The cell parameters of the proposed cell were found to be independent of the electron mobility ($\mu_n$) of the n-MoS$_2$ layer, which has been varied in the range of 517–50 cm$^2$ V$^{-1}$ s$^{-1}$.

3.2 Effect of the a-Si:H(i) layer thickness

In the HIT solar cell, an intrinsic layer of a-Si:H is inserted, mainly for passivation of the c-Si surface in the cell.34 Moreover, the insertion of the thin intrinsic layer also contributes to the depletion region, as well as to the drift current and electric field strength.39 Fig. 3a and b shows the dependence of the cell parameters on the thickness variation of the a-Si:H(i) layer is in the 3 to 10 nm range. It can be observed in Fig. 3b that along with the increase of a-Si:H(i) thickness from 3 to 4 nm, the $V_{OC}$ was slightly enhanced from 691.4 to 693 mV owing to a minor
increase in the barrier height at the a-Si:H(i) layer and p-cSi interface.\textsuperscript{43} The $V_{OC}$ then became constant at 693 mV upon further increasing the thickness of a-Si:H(i). The $J_{SC}$ was found to decrease linearly from 34.56 to 34.08 mA cm\textsuperscript{-2}. It is reported that a thicker intrinsic layer increases the series resistance in the cell.\textsuperscript{29} Therefore, we observed a tiny change in the $V_{OC}$, the FF was found to reduce from 83.32% to 82.43%. Consequently, the $\eta$ obtained reduced from 19.91% to 19.51%. To observe the cell performance for the optimized bandgap energy of a-Si:H(i), a further simulation was carried out by varying the $E_g$ of a-Si:H(i) in the range 1.6 to 2 eV. However, the maximum $\eta$ = 19.19% was only obtained at $E_g$ = 1.6 eV. This might be because the absorption of the photons by the MoS\textsubscript{2} layer only corresponds to this $E_g$ of the a-Si:H(i) layer.

### 3.3 Optimization of the p-cSi layer

After optimizing the n-MoS\textsubscript{2} and a-Si:H(i) parameters to their optimal values, the simulation was further performed to optimize the parameters of the p-cSi layer, while keeping the parameters of n-MoS\textsubscript{2} and a-Si:H(i) at their optimal values, as discussed in the previous section. The results of the cell performance against variation in the parameters of the p-cSi layer are shown in Fig. 4a and b. It is observed in Fig. 4b that when the $N_A$ is increased from $10^{15}$ to $10^{17}$ cm\textsuperscript{-3}, the $V_{OC}$ also increased from 691.2 to 699.2 mV owing to the higher $eV_{bi}$ with $N_A$ according to eqn (1). Similarly, $J_{SC}$ was also found to increase from 34.23 to 39.15 mA cm\textsuperscript{-2} as the increased $eV_{bi}$ pushes the photogenerated carriers effectively from the depletion region into the contact region without experiencing a recombination effect or the charge carrier trapped effect in the neutral region. This resulted in an increment in the $J_{SC}$.\textsuperscript{27} The increment in the FF from 81.48% to 82.76% can be attributed to the reduction of the sheet resistance as $J_{SC}$ is also increased. These changes lead to an improvement in $\eta$ from 19.46% to 21.88%. Hence, $N_A = 10^{17}$ cm\textsuperscript{-3} with a maximum $\eta$ of 21.88% is considered to be the optimal value for the c-Si layer.

To understand the effect of $N_C$ and $N_V$ on the performance of the HIT solar cell, we varied these parameters within the range of $3 \times 10^{19}$ to $1 \times 10^{21}$ cm\textsuperscript{-3} for the p-cSi layer. It can be observed from Fig. 4c and d, with the increase in the $N_C/N_V$, the $V_{OC}$ decreased linearly from 699.2 to 560.2 mV. According to eqn (1), with the increase in the $N_V$ of p-cSi layer the $eV_{bi}$ decreases and therefore $V_{OC}$ also decreases. In contrast, the value of $J_{SC}$ shows a small increase from 37.81 to 37.91 mA cm\textsuperscript{-2} with $N_C/N_V$. It has also been reported that $N_C/N_V$ influences the bandgap as well as the absorption of photons.\textsuperscript{28} It can be estimated that for $N_C/N_V > 3 \times 10^{19}$ cm\textsuperscript{-3}, the high absorption of photons in the active silicon layer increased the $G$ of electron-

![Fig. 4](image-url) Optimization of the p-cSi layer: (a) and (b) acceptor concentration $N_A$ (cm\textsuperscript{-3}), (c) and (d) effective conduction band and valance band density $N_C/N_V$ (cm\textsuperscript{-3}), (e) and (f) thickness (nm), (g) and (h) number of layers of MoS\textsubscript{2}, and (i) and (j) layer thickness of a-Si:H(i). The optimized parameters of a-Si:H(i) were maintained as: thickness = 3 nm, $E_g$ = 1.6 eV, and the parameters for n-MoS\textsubscript{2} were maintained as: $N_D = 10^{18}$ cm\textsuperscript{-3}, $N_C/N_V = 3 \times 10^{20}$ cm\textsuperscript{-3}, number of layers = 3, $E_g = 1.47$ eV, $\chi = 4.1$ eV and $\epsilon_r = 6$. 

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hole pairs. In Fig. 4d, the FF showed a deterioration from 82.76% to 81.02%, which resulted in the $\eta$ dropping to 17.2% from 21.88%. The maximum value of $\eta = 21.88\%$ was obtained at $N_C/N_V = 3 \times 10^{19} \text{ cm}^{-3}$.

In solar cell technology, the thickness of the p-cSi wafer plays an important role in the fabrication of HIT solar cells. Fig. 4e and f represents the variation of cell parameters as a function of the p-cSi wafer thickness from 50 to 500 $\mu$m. In Fig. 4f, the $V_{oc}$ remains constant at 699.2 mV. Upon a further increase in the thickness, the $V_{oc}$ reduced sharply to 697.7 mV and again remained constant up to a thickness of 350 $\mu$m. Above this thickness, the $V_{oc}$ was found to deteriorate to the value 696.1 mV and becomes independent of the change of thickness. This variation may be due to the variation in the recombination of the photo-generated carriers under open circuit conditions. The observed enhancement in the $J_{sc}$ from 36.22 to 40.09 mA cm$^{-2}$ can be ascribed to the boost in the generation of the charge carriers with the increase in the p-cSi thickness under short circuit conditions. The FF was observed to increase slowly from 82.72% to 82.96% owing to the reduction in the series resistance. These processes help to increase the $\eta$ from 20.95% to 23.15% at a thickness of 500 $\mu$m.

To study the role of the number of layers of n-MoS$_2$ and the a-Si:H(i) layer thickness with the best optimized p-cSi parameters, the proposed cell was again simulated by varying the number of layers of MoS$_2$ and the thickness of a-Si:H and the results are depicted in Fig. 4g, h and i, j respectively. From Fig. 4g and h, it can be clearly seen that the $V_{oc}$ increased from 696.1 to 699.2 mV when the number of layers of n-MoS$_2$ was increased from 3 to 5. Furthermore, the increase in the number of layers to 6$V_{oc}$ remains constant at 699.2 mV. On the other hand, the $J_{sc}$, FF, and $\eta$ were observed to decrease with the increase in the number of layers. The $J_{sc}$ decreased from 40.09% to 39.42%, the FF from 82.96% to 82.25 and the $\eta$ from 23.15% to 22.67%. In Fig. 4i and j, as the layer thickness of a-Si:H(i) was changed to 6 from 3 nm, the $V_{oc}$ gave a constant value of 696.1 mV and increased slightly to 697.7 mV when the thickness was increased to 6 nm. The $V_{oc}$ then became independent of the
thickness even when it was increased to 10 nm. The \( J_{SC} \) was found to decline from 40.09 to 39.05 mA cm\(^{-2}\) with the thickness of a-Si:H(i). The FF was found to decrease from 82.96% to 82.38% and a minimum \( \eta \) of 22.14% was achieved at 10 nm.

### 3.4 Simulation and optimization of the front contact (graphene) parameters

In a solar cell, contact plays a transparent conducting electrode role in the solar cell by allowing the light to transmit through and maintain a high electrical conductivity. Fig. 5a and b shows the dependence of the HIT solar cell parameters on the variation of the graphene layer (front contact) number. It is observed in Fig. 5b that with the increase in the number of graphene layers from 1 to 3, the \( V_{OC} \) remained constant at 697.7 mV. The reason behind this consistency might be the decrease in the recombination rate which limits the reduction of the charge carrier generation under open-circuit voltage conditions. However, upon further increasing of the graphene layer number to 4, the absorbed light might not be sufficient to produce an efficient electron–hole pair, which causes the \( V_{OC} \) to slightly decrease to 696.5 mV and then become constant with an increase in the layer number. On the other hand, the \( J_{SC} \) was observed to decline linearly from 44.25 to 40.09 mA cm\(^{-2}\) when the number of layers of graphene was increased the optical observed to decline linearly from 44.25 to 40.09 mA cm\(^{-2}\). When the number of layers of graphene was increased, the optical transmittance was reduced and hence the \( G \) of the charge carriers decreased and therefore the \( J_{SC} \) reduced too. Under short circuit conditions, the photo-generated carriers could be trapped close to the graphene/n-MoS\(_2\) junction. Therefore, we have observed a linear decrease in the \( J_{SC} \), which also, in turn, reduced the \( \eta \) from 25.61% to 23.15%. An insignificant change in the FF was found from 82.95% to 82.96%.

The presence of a strong covalent bond between the C and Mo atoms or the presence of a dangling bond of sulfur present in the interfaces affects the interfacial barrier height and a variation in the barrier height results in a variation in the contact resistance.\(^{60,61}\) Usually, the contact resistance is a vital factor that affects the solar cell performance.\(^{24}\) However, many experimental reports suggest that by controlling the Fermi level (i.e. the work function) of graphene, the contact resistance can be minimized in the graphene/MoS\(_2\) interfaces.\(^{63,64}\) Therefore, in this work, we have focused primarily on the work function of graphene. The depicted results shown in Fig. 5c and d, show the variation of the cell parameters with the variation of the graphene work function (\( \Phi_{Gr} \)) from 4.31 to 4.9 eV. A large reduction in the \( V_{OC} \) was observed in Fig. 5d, in which it decreased from 697.7 to 141.4 mV with an increase of \( \Phi_{Gr} \). From eqn (2), it can be observed that with the increase in \( \Phi_{Gr} \), the potential barrier energy \( E_{bi} \) of graphene/n-MoS\(_2\) decreases. It has also been reported that when the \( \Phi_{TCO} \) (contact) of Si HIT solar is low, the \( E_{bi} \) of the TCO (transparent conducting oxide)/n-type emitter has the same direction as that of the \( E_{bi} \) of the n-emitter/p-Si. On the other hand, when the \( \Phi_{TCO} \) (contact) is high, the \( E_{bi} \) of the TCO/n-type emitter contact will have an inverted direction to that of the \( E_{bi} \) of the n-emitter/p-Si junction. Moreover, with the increase in the \( \Phi \) of the TCO contact in the silicon HIT solar cell, the depletion region in the emitter region increases and widens and results in the overlap of the contact/n-type emitter region and the n-type emitter/p-type silicon junction region if the emitter is not sufficiently thin enough.\(^{4}\) Thus, the higher \( \Phi_{Gr} \) might increase the possibility of overlapping between the graphene/n-MoS\(_2\) depletion region and the n-MoS\(_2\)/p-cSi depletion region, which has resulted in a reduction in the \( V_{OC} \). In contrast, owing to the overlap of the graphene/n-MoS\(_2\) depletion region and the n-MoS\(_2\)/p-cSi depletion region, the \( E_{bi} \) of n-MoS\(_2\)/p-cSi reduces. This results in a reduction of the built-in electric field which is unable to push the photo-generated carriers effectively to their respective sides under short circuit conditions and thus the \( J_{SC} \) is observed to decline linearly from 44.25 to 40.09 mA cm\(^{-2}\) with an increase in the \( \Phi_{Gr} \). The overall reduction in the \( V_{OC} \) and \( J_{SC} \) reduced \( \eta \) from 25.61% to 23.15%. The maximum \( \eta \) of 25.61% was achieved at \( \Phi_{Gr} = 4.31 \) eV of pristine graphene.

To validate our simulated results, a comparison has been performed by considering the best-optimized values of n-MoS\(_2\) and a-Si:H(i) with the practically available p-cSi parameters by varying the \( \Phi_{Gr} \) and p-cSi thickness within the range of 4.31–4.9 eV and the 50–500 μm range respectively, as depicted in Fig. 5e–h and Table 4, using the practically available data for p-cSi.\(^{22,65}\) It can be seen from Fig. 5e and f, that the maximum \( \eta \) =

### Table 4 Summary of the most optimized cell

<table>
<thead>
<tr>
<th>Cell parameter</th>
<th>Most optimized cell (before optimization of the parameters of the graphene layers)</th>
<th>Graphene layer number optimized cell (after optimization of n-MoS(_2) and p-cSi)</th>
<th>n-cSi wafer optimized cell for practically available silicon parameters</th>
</tr>
</thead>
<tbody>
<tr>
<td>( V_{OC} ) (mV)</td>
<td>696.1</td>
<td>697.7</td>
<td>697.7</td>
</tr>
<tr>
<td>( J_{SC} ) (mA cm(^{-2}))</td>
<td>40.09</td>
<td>44.25</td>
<td>43.27</td>
</tr>
<tr>
<td>FF (%)</td>
<td>82.96</td>
<td>82.95</td>
<td>82.82</td>
</tr>
<tr>
<td>( \eta ) (%)</td>
<td>23.15 [@ 3L n-MoS(<em>2) at ( N</em>{E} = 10^{18} ) cm(^{-2}), ( N_{D}/N_{E} = 3 \times 10^{20} ) cm(^{-2}), ( E_{g} = 1.47 ) eV] ( \chi = 4.47 ) eV, ( \epsilon_{i} = 6, \mu_{n} = 517 ) cm(^{-1}) V(^{-1}) s(^{-1}), ( \mu_{p} = 8.5 ) cm(^{-1}) V(^{-1}) s(^{-1}), and @ 6 nm a-Si:H(i) at ( E_{g} = 1.6 ) eV and @ 500 μm p-cSi at ( N_{E} = 1 \times 10^{17} ) cm(^{-2}), ( N_{D}/N_{E} = 3 \times 10^{19} ) cm(^{-2}), ( \chi = 4.05 ) eV and @ 5L graphene at ( \Phi = 4.31 ) eV]</td>
<td>25 [@ 3L n-MoS(<em>2) at ( N</em>{D} = 10^{18} ) cm(^{-2}), ( N_{D}/N_{E} = 3 \times 10^{20} ) cm(^{-2}), ( E_{g} = 1.47 ) eV, ( \chi = 4.47 ) eV, ( \epsilon_{i} = 6, \mu_{n} = 517 ) cm(^{-1}) V(^{-1}) s(^{-1}), ( \mu_{p} = 8.5 ) cm(^{-1}) V(^{-1}) s(^{-1}), and @ 6 nm a-Si:H(i) at ( E_{g} = 1.6 ) eV and @ 500 μm p-cSi at ( N_{E} = 1 \times 10^{17} ) cm(^{-2}), ( N_{D}/N_{E} = 3 \times 10^{19} ) cm(^{-2}), ( \chi = 4.05 ) eV and @ 1L graphene at ( \Phi = 4.31 ) eV]</td>
<td>25 [@ 3L n-MoS(<em>2) at ( N</em>{D} = 10^{18} ) cm(^{-2}), ( N_{D}/N_{E} = 3 \times 10^{20} ) cm(^{-2}), ( E_{g} = 1.47 ) eV, ( \chi = 4.47 ) eV, ( \epsilon_{i} = 6, \mu_{n} = 517 ) cm(^{-1}) V(^{-1}) s(^{-1}), ( \mu_{p} = 8.5 ) cm(^{-1}) V(^{-1}) s(^{-1}), and @ 6 nm a-Si:H(i) at ( E_{g} = 1.6 ) eV and @ 500 μm p-cSi at ( N_{E} = 5 \times 10^{16} ) cm(^{-2}), ( N_{D}/N_{E} = 2.8 \times 10^{19} ) cm(^{-3}), ( \chi = 4.05 ) eV and @ 1L graphene at ( \Phi = 4.31 ) eV]</td>
</tr>
</tbody>
</table>

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25% was obtained at $\Phi_{\text{Gr}} = 4.31$ eV, which is close to our best-optimized results as shown in Fig. 5c and d. Similarly, in Fig. 5g and h, the same maximum $\eta = 25\%$ was achieved for a 500 µm thick p-cSi wafer.

### 3.5 Variation and simulation of the front contact and back contact material

In this section, a comparison of the cell parameters has been performed by changing the front contact material graphene to ITO and Al$^{19}$ and the back contact to Ag. As seen in Fig. 6a and b the thickness of ITO is considered to be 80 nm and the $\Phi_{\text{ITO}}$ has been varied from 4.40–4.50 eV.$^{34}$ The maximum values for $V_{\text{OC}}$, $J_{\text{SC}}$, FF and $\eta$ were obtained and found to be 625.8 mV, 31.47 mA cm$^{-2}$, 80.41% and 15.33% respectively. Similarly, in Fig. 6c and d, when $\Phi_{\text{Al}}$ was varied, the maximum values for $V_{\text{OC}}$, $J_{\text{SC}}$, FF, and $\eta$ were found to be 650.8 mV, 4.36 mA cm$^{-2}$, 82.79% and 2.353%, respectively. In both cases, $\eta$ was significantly lower than that of $\eta$ obtained using the graphene layer as a contact.

Fig. 6e and f shows the variation in the cell parameters when the back contact was changed from Au to Ag and the $\Phi_{\text{Ag}}$ was maintained from 4.64 to 4.74 eV. It was observed that in this range of $\Phi$ for Ag, the $V_{\text{OC}}$ increased from 664.8 to 677.3 mV, whereas the $J_{\text{SC}}$ remained constant at 42.76 mA cm$^{-2}$. The FF and $\eta$ were observed to decrease from 82.72% to 83.5% and 23.51% to 24.19%, respectively. This $\eta$ was close to our simulated $\eta_{\text{max}}$ value, that is, 25.61% when we used Au as a contact. Here, the back contacts have been considered as the uniform thin film deposited on the backside of p-cSi.

#### 3.6 Maximum power and series resistance

The proposed solar cell as shown in Fig. 1a was simulated and characterized under a standard AM1.5G spectrum and forward voltage in the range of 0 to 0.7 V. The $JV$ characteristics of the best optimized solar cell generated by the software are shown in Fig. 7. The maximum power delivered by the cell, as well as the

<table>
<thead>
<tr>
<th>Table 5</th>
<th>Graphene and MoS$_2$ silicon-based solar cells</th>
</tr>
</thead>
<tbody>
<tr>
<td>Type of study</td>
<td>Solar cell structure</td>
</tr>
<tr>
<td>Experimental</td>
<td>ITO/graphene/MoS$_2$/n-cSi/(Ti/Ag)</td>
</tr>
<tr>
<td>Experimental</td>
<td>Au/graphene/MoS$_2$/n-Si/In</td>
</tr>
<tr>
<td>Experimental</td>
<td>Au/graphene/MoS$_2$/n-Si/Au</td>
</tr>
<tr>
<td>Experimental</td>
<td>Pd/n-MoS$_2$/i-SiO$_2$/p-Si/In</td>
</tr>
<tr>
<td>Experimental</td>
<td>Ni/graphene/MoS$_2$/p-cSi/Al</td>
</tr>
<tr>
<td>Theoretical</td>
<td>TCO/MoS$_2$/SiGe:H/p-Si/Al</td>
</tr>
<tr>
<td>Theoretical</td>
<td>Graphene/n-MoS$_2$/a-Si:H/p-cSi/Au</td>
</tr>
</tbody>
</table>
series resistance ($R_s$), was calculated from the $IV$ characteristics and found to be $25.4 \text{ mW cm}^{-2}$ and $2.5 \Omega \text{ cm}^2$ was achieved respectively (see ESIF).

Finally, a comparison between the experimental and theoretical demonstration of graphene, MoS$_2$, and Si-based solar cells was performed and the results are detailed in Table 5. However, except for our work none of the studies used graphene as a contact material or TCE.

### 4. Conclusions

In order to develop an efficient HIT solar cell, a graphene/n-MoS$_2$/a-Si:H(i)/p-cSi/Au structure has been proposed and simulated using AFORS-HET v 2.5. The software individual effects of the six parameters of the n-MoS$_2$ layer were analyzed individually. After optimizing the parameters of the n-MoS$_2$, a-Si:H(i), and p-cSi layers, an optimum efficiency of 23.15% was achieved. As the contact material in a solar cell has an adverse effect on the cell performance, a further simulation was performed to observe the effect of graphene on the proposed HIT solar cell by varying the number of layers and the work function. From this simulation, a maximum efficiency of 25.61% was achieved for single-layer graphene at a work function of 4.1 eV. On the other hand, by changing the front contact graphene to ITO and Al we achieved efficiencies of 15.33% and 2.35%. This confirms that graphene could be an efficient contact material for use in an n-MoS$_2$/a-Si:H(i)/p-cSi/Au HIT solar cell. Our simulated results establish that the graphene layer could be an effective contact TCE material and n-MoS$_2$ could be an efficient emitter layer in a single facial n-MoS$_2$ and p-cSi based HIT solar cell.

## Conflicts of interest

There are no conflicts to declare.

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